

Substitute for form 1449/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>				<b>Complete if Known</b>	
				Application Number	10/539,649-Conf. #6622
				Filing Date	June 15, 2005
				First Named Inventor	Kazuhiko Oda
				Art Unit	1775
				Examiner Name	A. A. Turner
Sheet	1	of	1	Attorney Docket Number	20239/0201924-US0

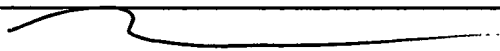
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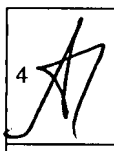
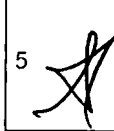
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<i>AT</i>	CA	Jung et al., "The Investigation of Thermal Effect on the Properties of Pulsed Laser Deposited Diamond-Like Carbon Films," <i>Thin Solid Films</i> , 332:103-108, 1998.	
<i>AT</i>	CB	Office Action in co-pending Japanese Application No. 2001-342218, issued by Japanese Patent Office, August 14, 2007, English translation of document.	

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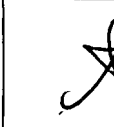
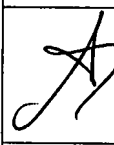
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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10539649	
	Filing Date		2005-06-15	
	First Named Inventor	Kazuhiko Oda		
	Art Unit	1775		
	Examiner Name	Not Yet Assigned		
	Attorney Docket Number	20239/0201924-US0		

4 	4	2002322555	JP		2002-11-08	Kobe Steel Ltd	<input checked="" type="checkbox"/>
5 	5	2002008217	JP		2002-01-11	Hitachi Metals Ltd	<input checked="" type="checkbox"/>


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( Not for submission under 37 CFR 1.99)

Application Number	10539649
Filing Date	2005-06-15
First Named Inventor	Kazuhiko Oda
Art Unit	1775
Examiner Name	Not Yet Assigned <i>A. Turner</i>
Attorney Docket Number	20239/0201924-US0

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<i>1</i>	1	2001192864	JP		2001-07-17	Sumitomo Electric Ind Ltd		<input checked="" type="checkbox"/>
<i>2</i>	2	02022458	JP		1990-01-25	Matsushita Electric Ind Co Ltd		<input checked="" type="checkbox"/>
<i>3</i>	3	07215795	JP		1995-08-15	Kyocera Corp		<input checked="" type="checkbox"/>